



Inventor: Gurtej S. Sandhu, et al.

Title: Deposition Methods and Apparatuses Providing Surface Activation

Assignee: Micron Technology, Inc.

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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 04 Dec 2002

Attorney: 

James E. Lake  
Reg. No. 44,854

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